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In re Application of  
ZAIT et al.

U.S. Application No.: 10/564,972

PCT No.: PCT/IL04/00653

Int. Filing Date: 18 July 2004

Priority Date: 18 July 2003

Attorney Docket No.: P-8503-US

For: METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN  
PHOTOMASKS

Dear Nikolay Guletsky:

You are named as an inventor in the above identified United States patent application, filed under the provisions of 37 CFR 1.47(a) and 35 U.S.C. 116. Should a patent be granted, you will be designated as an inventor.

As a named inventor, you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or to make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent agent or attorney presenting written authorization from you. If you care to join in the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

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